ATTY DKT. No.: U.S. SERIAL NO.: FILED: APPLICANT: TITLE:

AMAT/5320.Y1/DSM/BCVD/JW
09/755,516 CONF. NO.: 5078
JAN. 4, 2001
APPLIED MATERIALS, INC.
APPARATUS HAVING PLATFORMS POSITIONED FOR PRECISE
CENTERING OF SEMICONDUCTOR WAFERS DURING
PROCESSING
SCHIEVE, ET AL.



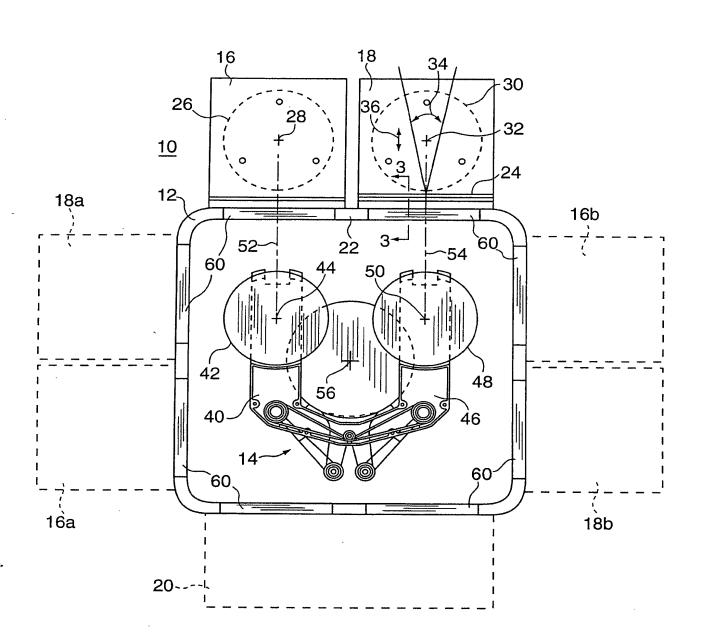


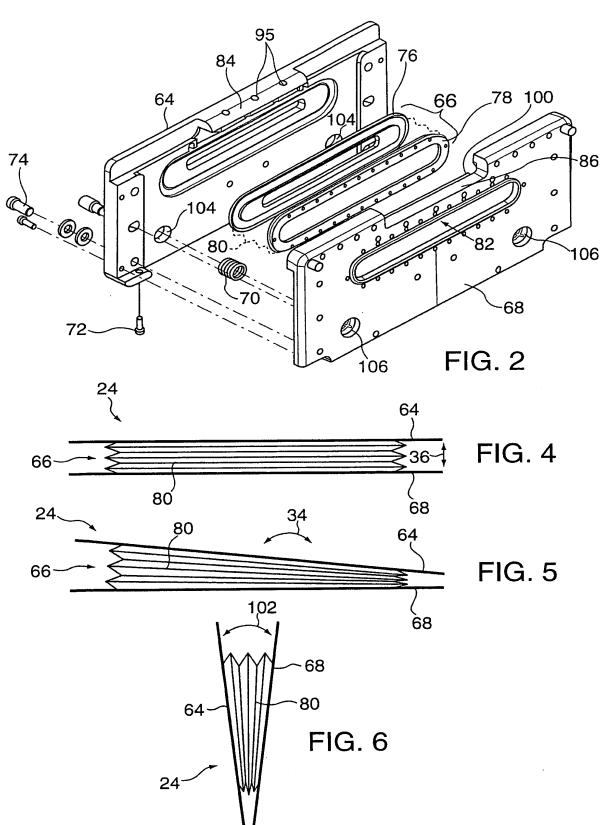
FIG. 1

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APPARATUS HAVING PLATFORMS POSITIONED FOR PRECISE
CENTERING OF SEMICONDUCTOR WAFERS DURING ATTY DKT. No.: U.S. SERIAL NO .: FILED: APPLICANT: TITLE: PROCESSING INVENTOR: 3/3 8 92 82 8 86 78 84 96 98 106--89 <u>Ó</u> 12 8